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Appl. No. 10/800,450 Amdt. Dated January 26, 2005 Reply to Office action of July 27, 2004

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/800,450

**Applicant** 

Emmanuel Hadji, et al.

Filed

March 15, 2004

Title

METHOD FOR FORMING AN OPTICAL SILICON LAYER ON A

SUPPORT AND USE OF SAID METHOD IN THE PRODUCTION

OF OPTICAL COMPONENTS

Confirm No. :

1230

TC/A.U.

2825

Examiner

Chuong A. Luu

Docket No.

33019US1

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

VIA FACSIMILE NO.: 1-703-872-9306

## AMENDMENT A

Sir:

This amendment is filed in response to the Office action dated July 27, 2004. The three-month period for responding to the Office action expired on October 27, 2004. Accordingly, applicants request and hereby petition for a three-month extension of time up to and including January 27, 2004. The Commissioner is authorized to charge our Deposit Account No. 16-0820, Order No. 33019US1 in the amount of \$1020.00 for the fee associated with the three-month extension of time.

Remarks/Arguments begin on page 2 of this paper.

I hereby certify that this correspondence is	being facsimile transmitted to	the United States Patent and
Trademark Office on the date indicated below.		
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Una L. Lauricia	سكاحس	<u> (- シム - 05</u>
Name of Attorney for Applicant(s)	Signature of Attorney	Date
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